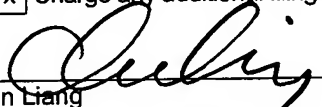


<b>AMENDMENT TRANSMITTAL LETTER</b>			Docket No. 108298727US		
Application No. 10/636,021-Conf. #1017	Filing Date August 6, 2003	Examiner E. B. Chen	Art Unit 1765		
Applicant(s): Palsulich et al.					
Invention: MICROFEATURE WORKPIECE PROCESSING SYSTEM FOR, e.g., SEMICONDUCTOR WAFER ANALYSIS					
<b>TO THE COMMISSIONER FOR PATENTS</b>					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
<b>Total Claims</b>	28	- 48 =		x	
<b>Independent Claims</b>	3	- 5 =		x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify): Extension for response within first month					120.00
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					<b>120.00</b>
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. <u>50-0665</u> in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> A check in the amount of \$ <u>120.00</u> to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>50-0665</u> as described below.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 Chen Liang Attorney/Agent Reg. No.: 51,945			Dated: <u>March 1, 2006</u>		
PERKINS COIE LLP P.O. Box 1247 Seattle, Washington 98111-1247 (206) 359-8000					



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: DAVID A. PALSULICH ET AL.

APPLICATION NO.: 10/636,021

FILED: AUGUST 6, 2003

FOR: **MICROFEATURE WORKPIECE  
PROCESSING SYSTEM FOR, E.G.,  
SEMICONDUCTOR WAFER ANALYSIS**

EXAMINER: ERIC B. CHEN

ART UNIT: 1765

CONF. NO: 1017

**Amendment Under 37 C.F.R. § 1.114**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated November 1, 2005 in the above-identified application, and is being filed concurrently with a Request for Continued Examination under 37 C.F.R. §1.114. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2.